



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HU et al.

Confirmation No. 4890

Application No. 09/924,265

Group Art Unit: 3736

Filed: August 7, 2001

Examiner: J. Hoekstra

For: **SYSTEM AND METHOD FOR VISION EXAMINATION UTILIZING
FAULT DETECTION**

RESPONSE AND AMENDMENT UNDER 37 CFR §1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a full and complete response to the Office Action having a mailing date of October 11, 2006. The three month shortened statutory period to respond to the Office Action was set to expire January 11, 2006, making this a timely filed response.

Entry of this Response and Amendment is respectfully requested since it is believed to place the application in condition for allowance or in better condition for appeal and does not raise any new issues that require further consideration and/or search.

Amendments to the Claims begin on page 2 and include a full listing of claims.

Remarks/Arguments begin on page 14.